Attorney Docket No.: 12732-0171001 / US6695

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Masaharu Nagai et al. Art Unit: 1795

Serial No.: 10/694,986 Examiner: Daborah Chacko Davis

Filed : October 29, 2003 Conf. No. : 5334

Title : METHOD FOR REMOVING RESIST PATTERN AND METHOD FOR

MANUFACTURING SEMICONDUCTOR DEVICE

MAIL STOP Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JANUARY 28, 2010

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.